A New Route for Preparing CdS thin Films by Chemical Bath Deposition Using EDTA as Ligand

A. V. Feitosa[‡], M. A. R. Miranda[†], J. M. Sasaki[†], and M. A. Araújo-Silva[‡],

[‡] Lab. de Optoeletroquímica e Lab. de Filmes Finos, Departamento de Física,

Universidade Federal do Ceará, Centro de Ciências, Campus do Pici, Caixa Postal 6030, 60455-760 Fortaleza, Ceará, Brazil

[†] Lab. de Raios X, Departamento de Física, Universidade Federal do Ceará, Centro de Ciências,

Campus do Pici, Caixa Postal 6030, 60455-760 Fortaleza, Ceará, Brazil

Received on 31 March, 2003

Progress is reported towards the development of a new route to obtain cadmium sulfide (CdS) thin films by using ethylene-diamine-tetra-acetic acid (EDTA) ligand on the chemical bath deposition (CBD) method. Different chemical baths are used to study changes in the structures of the CdS films for different EDTA concentrations. X-ray diffraction (XRD) is used to prove the structural characterization of the samples, and to obtain the grain size with the Scherrer's equation. The pH variations during the growth also affect the structural film quality, and it was verified by using ammonia chloride as an auxiliar-buffer plus Triton-X100.

1 Introduction

In recent years, polycrystalline CdS thin films have received intensive attention due their very important role on the photovoltaic technology and optoelectronic devices. It has been used as a partner of several types of thin film solar cells, such as, Cu₂S, CuInSe₂, and CdTe. Specifically, CdTe/CdS heterojunction solar cells with efficiency of about 16% have been reported [1]. CdS thin film has been obtained by several methods, such as, electrodeposition, vacuum evaporation, screen printing, photochemical deposition, CBD, spray pyrolysis, and sputtering. CdS thin film manufacture technology has been the subject of several reviews [2 - 4], where more details about it can be seen.

Particularly, the CBD technique is an easy low-cost process, and useful for large-area industrial applications, reason for which it has been very used in the current days. CBD is a process to achieve high quality films, which are obtained by adjusting the pH, temperature and reagent concentrations.

Normally, for obtaining CdS thin films by CBD in aqueous solution a cadmium salt is used as the Cd ion source, thiourea as the sulfur source, a base to adjust the pH of solution, and a ligand to control the precipitation of chalcogenides and hydroxides. As far as we know, CdS thin films have been mainly obtained through CBD with ammonia and/or ethylenediamine (Lewis base) ligand [5 - 8]. Despite the advances in the processes of achieve CdS thin films many issues are opened, and new routes are welcome.

EDTA is an amino-derived organic-compound known to be a strong hexdentate chelanting agent. It forms a complex with metal ions and dissociates reversibly at a low rate. Lade and Lokhande [9] have used EDTA in the electro deposition of CdS thin films from non-aqueous bath. Furthermore, EDTA has been used in several process involving CdS colloid [10] or cadmium particles [11, 12]. EDTA affects the adsortion and desortion processes of cadmium in red soil (ferrisoils) [13], and also, it affects the growth of CdS crystalline thin films by photochemical deposition [14].

In this work, we show a new route to the deposition of CdS thin films using CBD technique with EDTA ligand. Different concentrations of EDTA are proved to estimate the structural quality of the CdS thin films. Furthermore, the variation of pH during the growth is important in the structural film quality, and was observed experimentally by using ammonia chloride as an auxiliar-buffer. Triton-X100 (TX100) is a non-ionic surfactant that is widely employed in industry as a detergent, solubilizer, and emulsifier. In this work, it was employed with intention of improve the CdS film quality. The CdS thin films were characterized by XRD.

2 Experimental

CdS thin films were microstructurally characterized by XRD, at room temperature, using a thin-film setup (PHILIPS, model XPERT-PRO) with CuK α radiation operated at 40 kV and 40 mA. The grain sizes of polycrystalline film were inferred from experimental XRD using Bragg-Bretano geometry setup by using the Scherrer's equation [15].

CdS thin films were deposited using CBD technique on glass commercial slide plates degreased and cleaned thoroughly by ultrasonic using a standard procedure. The films were kept at 80 °C (\pm 1 °C) during the growth. The growth time for each bath was ca. 55 minutes under continuous stirring. Three different aqueous alkaline solution with distilled and deionized water, and analytical-grade reagents were used. The EDTA concentration has changed from 0.6

x 10^{-4} M to 3.0×10^{-4} M, with step of 0.3×10^{-4} M, called of C1 to C9, respectively. In the group one, the solution containing cadmium sulfide (CdSO₄) (Cd ion source) 0.003 M, thiourea (sulfur source) 0.06 M, ammonia (base and ligand) 2.3 M, and EDTA with four different concentrations, C1, C3, C5, and C7. In the group two the solution differs from the one by the addition of ammonia chloride (NH₄Cl), that forms a buffer-solution with ammonia to keep the pH = 11, and EDTA with four different concentrations, C2, C4, C6, C8. In the group three, the solution differs from the solution two by the addition of TX100 at the solution buffer.

3 Results and discussion

One of the parameter that acts on the film quality is the relative concentration of chemical species present in the solution. The variation of the EDTA concentration has been used to obtain a qualitative influence of the ligand and the buffer solution on the formation of CdS film. Initially, Cd^{2+} ion co-ordinates with EDTA ligand to form Cd[EDTA]²⁻ complex, that avoids the precipitation of undesirable material, as the cadmium hydroxide [Cd(OH)₂]. In the next step, the complex will be broken with the addition of S²⁻ ion, forming CdS. The CdS precipitation can take place either with the formation of colloids in the bulk of the solution (homogeneous reaction), or with the formation of a continuous film at the surface of the substrate (heterogeneous reaction) [7].

The obtained films were optically transparent, adherent, homogeneous and orange in color. X-ray patterns of samples of second solution group (with buffer solution, but without TX100) are shown in the Fig. 1. EDTA concentration of $C2 = 0.9 \times 10^{-4}$ M, $C4 = 1.5 \times 10^{-4}$ M, $C6 = 2.1 \times 10^{-4}$ M, and $C8 = 2.7 \times 10^{-4}$ M, were used and assigned to Fig. 1(a), (b), (c), and (d), respectively. The diffractogram show three peaks more intense, corresponding to the planes (111), (220) and (311), respectively, of the cubic phase of CdS film.

The grain size $(L_c = k\lambda\beta cos\theta)$ for all samples were calculated by means of Scherrer's equation [15], where k is related to the shape of the polycrystals, λ is the x-ray wavelength, β is the full-width at half maximum (FWHM) of the respective diffraction peak and θ is the Bragg angle. According to the SEM images (not shown) of the CdS polycrystals, was choice k = 1 for accounting the near spherical shape of the observed CdS. The parameter β in the equation above must be corrected with the instrumental width through the relation $\beta = \sqrt{\beta_{exp}^2 - \beta_{inst}^2}$, considering a Gaussian distribution for the diffracted peaks. The parameters β_{exp} and β_{inst} are the experimental and the instrumental linewidths, respectively. The value β_{inst} was determined using a LaB6 (NIST SR660) powder standard pattern.

Figure 2 shows the grain size obtained by Scherrer's equation for [111] cubic direction as a function of the EDTA concentrations for all samples prepared by this new route. The open up-triangle, the filled square, and the open circle represent the group one, two and three solution, respectively. We observe that the grain size have nanometric dimension, ranging approximately from 8.0 to 26 nm. The grain size increases when the group one go to group three, passing by

group two, indicating a better quality for the film of group three.



Figure 1. XRD of samples of the group two, with buffer solution and with different EDTA concentrations, as explained in text.



Figure 2. Grain size obtained using the Scherrer's equation, for all samples used in this work, as a function of EDTA concentration, as explained in text.

Figure 3 shows the XRD of the three films deposited at the same EDTA concentration of $C3 = 1.2 \times 10^{-4}$ M, in the Fig. 3(a) without buffer solution, in the Fig. 3(b) with addition of the buffer solution, and in the Fig. 3(c) the buffer solution plus TX100. It was observed that for all CdS film studied, their quality improves with solution-buffer and TX100. As the presence of buffer and TX100 keep the pH constant during the deposition, it was observed that the samples prepared by this way have improved the film quality.



Figure 3. XRD of three films with the same C3 EDTA concentration. Without buffer in (a), with buffer in (b), and with buffer plus TX100 in (c).

4 Conclusion

The microstructural properties of CdS thin films deposited by CBD has been tested at first time, as a function of the EDTA ligand concentration. The CdS films present a cubic structure for all sample obtained. XRD was used to obtain the polycrystaline size grain using the Scherrer's equation, and their quality. Addition of solution-buffer and TX100 increase the size grain and consequently the quality of the films.

Acknowledgement

A. V. F. was supported by PIBIC/CNPq. The authors would like to thank to MCT/CNPq, for their partial support (Project number 471496/01-4).

References

- [1] J. Britt, and C. Ferekides, Appl. Phys. Lett. 62, 2851 (1993).
- [2] T. L. Chu, and S. S. Chu, Solid-State Electronics 38, 533 (1995).
- [3] M. A. Green, Prog. Photovoltaics 9, 123 (2001).
- [4] K. L. Chopra, S. Major, and D. K. Pandya, Thin Solid Films 102, 1 (1983).
- [5] J. M. Dona and J. Herero, J. Electrochem. Soc. 144, 4091 (1997).
- [6] A. E. Rakhshani, and A. S. Al-Azab, J. Phys.: Condens. Matter 12, 8745 (2000).
- [7] M. A. Martínez, C. G, and J. Herrero, Appl. Sur. Sci. 136, 8 (1998).
- [8] G. Contreras-Puente et al., Thin Solid Films 361, 378 (2000).
- [9] S. J. Lade, and C. D. Lokhande, Mat. Chem. Phys. 49, 160 (1997).
- [10] J. W. Park, K. R. Min, and E. Y. Jeung, B. Kor. Chem. Soc. 9, 408 (1988).
- [11] T. I. Igumenova *et al.*, J. Photochem. and Photobiology A: Chem. **94**, 205 (1996).
- [12] T. Sugimoto, G. E. Dirige, and A. Muramatsu, J. Colloid and Interface Sci. 182, 444 (1996).
- [13] D. M. Zhou, S. Q. Wang, and H. M. Chen, J. Environ. Sci. Chi. 13, 153 (2001).
- [14] R. Padmavathy et al., Mat. Lett. 53, 321 (2002).
- [15] L. S. Birks, and H. Friedman, J. Appl. Phys. 16, 687 (1946).